

J4902 U.S. PTO  
09/325951  
06/04/99

Sir:

Transmitted herewith for filing is the Patent Application of:

Inventor: MIN-HSIUNG CHIANG, JIN-YUAN LEE AND JENN MING HUANG

For: METHOD FOR FORMING HIGH PURITY SILICON OXIDE FIELD OXIDE ISOLATION REGION

JC586 U.S. PTO



Enclosed are:

06/04/99

- ☒ 1 sheets of drawing(s) - formal.
- ☒ An assignment of the invention to Taiwan Semiconductor Manufacturing Company
- ☐ An associate power of attorney

The filing fee has been calculated as shown below:

	(Col. 1)	(Col. 2)	OTHER THAN A SMALL ENTITY	
FOR:	NO. FILED	NO. EXTRA	RATE	FEE
BASIC FEE				\$ 760.
TOTAL CLAIMS	10 -20=	0	x 18 =	\$ 0.
INDEP CLAIMS	2 -3=	0	x 78 =	\$ 0.
MULTIPLE DEPENDENT CLAIM PRESENTED			+ 260 =	
SUB TOTAL				\$ 760.
ASSIGNMENT				\$40.
TOTAL				\$ 800.

- ☒ Please charge my Deposit Account No. 19-0033 in the amount of \$ 800. A duplicate copy of this sheet is enclosed.
- ☒ The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 19-0033. A duplicate copy of this sheet is enclosed.
- ☒ Any additional filing fees required under 37 CFR \$1.16.
- ☒ Any patent application processing fees under 37 CFR \$1.17.

Respectfully submitted,  
*Stephen B. Ackerman*  
STEPHEN B. ACKERMAN, REG. NO. 37,761

SERIAL NUMBER	FILING DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.
09/325,951	06/04/99	438	2812	TSMC98-262

APPLICANT MIN-HSIUNG CHIANG, TAIPEI, TAIWAN; JIN-YUAN LEE, HSIN-CHU, TAIWAN;  
JENN-MING HUANG, HSIN-CHU, TAIWAN.

**\*\*CONTINUING DOMESTIC DATA\*\*\*\*\***

VERIFIED

RP None

**\*\*371 (NAT'L STAGE) DATA\*\*\*\*\***

VERIFIED

RP None

**\*\*FOREIGN APPLICATIONS\*\*\*\*\***

VERIFIED

RP None

IF REQUIRED, FOREIGN FILING LICENSE GRANTED 06/30/99

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	<input type="checkbox"/> Met after Allowance	STATE OR COUNTRY TWX	SHEETS DRAWING 1	TOTAL CLAIMS 10	INDEPENDENT CLAIMS 2
Verified and Acknowledged <u>RP</u> Examiner's Initials _____ Initials _____						

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TITLE	METHOD FOR FORMING HIGH PURITY SILICON OXIDE FIELD OXIDE ISOLATION REGION
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FILING FEE RECEIVED  \$760	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT NO. _____ for the following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of tim ) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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